

Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10748950	IKEDA, ROGER M.
	Examiner	Art Unit
	Koziol, Stephen R	2624

SEARCHED

Class	Subclass	Date	Examiner
382	168	4/21/2008	SRK
345	108	4/21/2008	SRK

SEARCH NOTES

Search Notes	Date	Examiner
Further text search for adjusting aperture movement rate	4/21/2008	SRK

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner